



PATENT
Attorney Docket No.: SAM-0396

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kun-Hyung Lee, *et al.*
Serial No.: 10/619,112
Filing Date: July 14, 2003
Title: APPARATUS AND METHOD FOR PROCESSING WAFERS

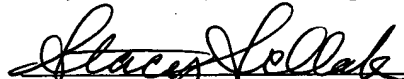
Examiner: Adams, Gregory W.
Group Art Unit: 3652

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

8-5-05

Date


Stacy Sedlak

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT A

Sir:

The following is in response to the Office Action dated May 6, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 10 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 11 of this paper.

An Appendix including amended drawing figures is attached following page 13 of this paper.